Docket No.: 085027-0106 **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 89518

Hui-Mei Chen, et al. : Confirmation Number: 3341

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Application No.: 10/786,807 : Group Art Unit: 2822

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Filed: February 25, 2004 : Examiner: BAC H. AU

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For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

INFORMATION DISCLOSURE STATEMENT

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being electronically-transmitted to the United States Patent and Trademark Office on <u>February 2, 2011.</u>

/Nicole San Nicolas/

Nicole San Nicolas

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

In general, this pending application and other applications and granted patents in the same portfolio were recently purchased through a transaction by a new owner. As part of the new owner's due diligence review of the portfolio prior to the purchase transaction, certain references were uncovered which may be relevant to this application.

10/786,807

Accordingly, out of an abundance of caution and in keeping with Applicants' obligation to

bring possibly relevant material to the attention of the examiner in this pending application,

Applicants cite such references in this IDS for the examiner's consideration.

This Information Disclosure Statement is being filed more than three months after the U.S.

filing date AND after the mailing date of the first Office Action on the merits, but before the

mailing of a Final Rejection or Notice of Allowance. Please charge the fee of \$180.00 to Deposit

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Please charge any shortage in fees due in connection with the filing of this paper, including

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Respectfully submitted,

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